

1 Inventor: Weimin Li et al.

2 Title: Semiconductor Processing Methods

3 Assignee: Micron Technology, Inc.



4  
5 **INFORMATION DISCLOSURE STATEMENT**

6 The Examiner's attention is directed to the references listed on the attached  
7 Form PTO-1449 and copies of which are attached.

8 Citation of these patents are respectfully requested.

9  
10 Respectfully submitted,

11  
12 Date: 1/20/99

13  
14 Attorney: David G. Latwesen

David G. Latwesen, Ph.D.  
Reg. No. 38,533

15 Date: Jan 14, 1999

16 Inventor: Weimin Li

Weimin Li

17 Date: 1-8-99

18 Inventor: John Q. Li

John Q. Li